	Application No.	Applicant(s)
Notice of Allowability	09/941,125	SANDHU ET AL.
	Examiner	Art Unit
	Arden B. Sperty	1771
The MAILING DATE of this communication apper All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this ap or other appropriate communication IGHTS. This application is subject to	correspondence address oplication. If not included
1. This communication is responsive to Remarks filed 7/12/0	4, Terminal Disclaimer filed 08/04/04	<u>4</u> .
2. The allowed claim(s) is/are <u>51-56,60-73,75-78 and 81-85</u> .		
3. The drawings filed on 30 June 2003 are accepted by the E	xaminer.	
4. ☐ Acknowledgment is made of a claim for foreign priority ur a) ☐ All b) ☐ Some* c) ☐ None of the:		
1. Certified copies of the priority documents have been received.		
2. Certified copies of the priority documents have been received in Application No		
 Copies of the certified copies of the priority dod International Bureau (PCT Rule 17.2(a)). Certified copies not received: 	cuments have been received in this	national stage application from the
Applicant has THREE MONTHS FROM THE "MAILING DATE" on noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	of this communication to file a reply ENT of this application.	complying with the requirements
5. A SUBSTITUTE OATH OR DECLARATION must be submi INFORMAL PATENT APPLICATION (PTO-152) which give	tted. Note the attached EXAMINER' s reason(s) why the oath or declara	S AMENDMENT or NOTICE OF tion is deficient.
6. CORRECTED DRAWINGS (as "replacement sheets") musi	be submitted.	
(a) ☐ including changes required by the Notice of Draftsperso	on's Patent Drawing Review (PTO-9	948) attached
1) ☐ hereto or 2) ☐ to Paper No./Mail Date		
(b) ☐ including changes required by the attached Examiner's Paper No./Mail Date	Amendment / Comment or in the O	ffice action of
Identifying indicia such as the application number (see 37 CFR 1.4 each sheet. Replacement sheet(s) should be labeled as such in the	34(c)) should be written on the drawin e header according to 37 CFR 1.121(d	gs in the front (not the back) of
7. DEPOSIT OF and/or INFORMATION about the depos attached Examiner's comment regarding REQUIREMENT F	it of BIOLOGICAL MATERIAL m	aust be submitted. Note the
Attachment(s)		
1. Notice of References Cited (PTO-892)	5. Notice of Informal Pa	atent Application (PTO-152)
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. 🔲 Interview Summary (PTO-413),
3. Information Disclosure Statements (PTO-1449 or PTO/SB/08 Paper No./Mail Date 07/12/04	Paper No./Mail Date), 7. ☐ Examiner's Amendm	ent/Comment
4. Examiner's Comment Regarding Requirement for Deposit		nt of Reasons for Allowance
of Biological Material	9. Other	1. , 0.
		Stephen Stem
	1	STEPHEN STEIN PRIMARY EXAMINER

Application/Control Number: 09/941,125 Page 2

Art Unit: 1771

ALLOWANCE

1. Claims 51-56, 60-73, 75-78, and 81-85 are currently allowed subsequent to consideration of Remarks filed 07/12/04 and Terminal Disclaimer filed 08/04/04.

Information Disclosure Statement

- 2. The information disclosure statement (IDS) submitted on 07/12/04 was filed after the mailing date of the Final Action on 04/13/04. The submission is in compliance with the provisions of 37 CFR 1.97. The information disclosure statement has been considered by the examiner and the references are not found to anticipate the claimed invention.
- 3. While the 5401674 reference teaches a layer sequence (in order of uppermost to lowermost layer) Al (fill)/ TiN (barrier)/ TiGe (Ti alloy comprising Ti and Ge)/ TiSi (titanium silicide layer)/ Si (substrate), the structure is not taught as lining a high aspect ratio contact hole. It follows that the reference does not teach the Ti alloy layer as a continuous, uniform layer on the walls and base layer of a contact hole. Depositing the layer sequence of the reference in a high aspect ratio contact hole would not have been obvious to one of ordinary skill in the art, as the dimensions of such a hole present special challenges for deposition of a continuous, uniform layer on the sidewalls and base.
- 4. The 4782380 reference teaches a layer sequence of (from outermost to innermost) Al/ TiN/ Al (fill)/ TiN (barrier)/ TiSi (titanium silicide layer)/ Si (substrate). The layer sequence, as seen in the drawings as formed in a contact hole, fails to include a titanium alloy layer between the TiN and TiSi layers. Review of the prior art fails to teach

Application/Control Number: 09/941,125

Art Unit: 1771

or fairly suggest a motivation for the inclusion of such a layer in the structure taught by the reference.

Reasons for Allowance

- 5. The following is an examiner's statement of reasons for allowance: The prior art of record is not seen to teach or fairly suggest the specific combination of claimed elements, including the particular layer sequence where a Ti alloy layer covers side walls and the base of a contact hole, the contact hole being of a high aspect ratio, and the particular sequence of layers comprising a TiN barrier laeyr/ Ti alloy layer/ TiSi layer wherein the alloy layer is especially a TiZn alloy.
- 6. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Arden B. Sperty whose telephone number is (571)272-1543. The examiner can normally be reached on M-Th, 08:00-16:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Terrel Morris can be reached on (571)272-1478. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Art Unit: 1771

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Arden B. Sperty Examiner Art Unit 1771

August 13, 2004

STEPHEN STEIN PRIMARY EXAMINER

LSK.